

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Application Number	10/700,279
Filing Date	November 3, 2003
First Named Inventor	Jun Yan
Group Art Unit	To be Assigned
Examiner Name	To be assigned
Attorney Docket Number	MVIS 02-24

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IDC-US Ref -10

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Examiner Initials	U.S. Patent Number	Name of Patentee	Date of Publication (MM-DD-YYYY)
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WJ	5,557,444	Melville, et al.	09/17/1996
WJ	5,629,790	Neukermans, et al.	05/13/1997
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IDC-For Ref -1

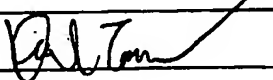
FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number	Country	Date of Publication (MM-DD-YYY)	English Translation Provided?
WJ	WO025170 A1	PCT	02/22/2003	G02B 26/08

IDC-Other Ref -2

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
WJ	CONANT, NEE, LAU and MULLER, "A Fast Flat Scanning Micromirror," 2000 Solid-State Sensor and Actuator Workshop, Hilton Head, SC, June 2000, pp.6-9
WJ	CONANT, NEE, LAU and MULLER, "Dynamic Deformation of Scanning Micromirrors," presented at IEEE/LEOS Optical MEMS 2000, Kauai, Hawaii, August 2000

Examiner Signature		Date Considered	6/10/05
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OMB 0651-0031